

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Masaaki OGINO et al.

Serial No.: 10/599,747

Filed: October 6, 2006

Title: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

VIA EFS - WEB

Group Art Unit:

Examiner:

Attorney Docket No.: FUJI:398

Confirmation No.: 3644

MAIL STOP: PCT
COMMISSIONER FOR PATENTS
P.O. Box 1450
ALEXANDRIA, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified application as follows prior to examination on the
merits